IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Reissue Application of:)
U.S. Patent No.: 5,792,261)
Inventor: Kiichi HAMA et al.)) Group Art Unit: Unassigned
Issued: August 11, 1998)) Examiner: Unassigned
Serial No.: Unassigned))
Filed: Concurrently Herewith))
For: PLASMA PROCESS APPARATUS	·))
Assistant Commissioner for Patents Washington, D.C. 20231	
Sir:	

CONSENT OF ASSIGNEE AND OFFER TO SURRENDER ORIGINAL PATENT

Tokyo Electron Limited ("Assignee"), owner of the entire, right, title and interest in U.S. Patent No. 5,792,261 by virtue of an assignment recorded at the U.S. Patent and Trademark Office on December 16, 1994, under Reel 7282, Frames 0552-0554, hereby consents to the filing of the above-identified reissue application.

Pursuant to 37 C.F.R. § 3.73(b), Assignee hereby states that the documents evidencing Assignee's ownership of the entire right, title, and interest in U.S. Patent No. 5,792,261 have been reviewed and certifies that to the best of Assignee's knowledge and belief, title is in the Assignee.

Pursuant to 37 C.F.R. § 1.178, Assignee hereby offers to surrender the original patent. The original patent, or an affidavit or declaration as to loss or

inaccessability of the original patent, will be submitted before the reissue application is allowed.

The undersigned is empowered to sign this Assent of Assignee and Offer to Surrender Patent on behalf of the Assignee.

TOKYO ELECTRON LIMITED

Signature: Tosh h ho Sufe

Name: Toshihiko Suga

Title: Vice President, Intellectual Property Dept.

Date: 27 Dec. 1999